WEST Search History

Hide Items Restore Clear Cancel

DATE: Wednesday, September 14, 2005

Set Nam	<u>e Query</u>	Hit Count	
DB=USPT; PLUR=YES; OP=OR			
L10	(11 same 12) and L9	7	
L9	427/\$7.ccls.	86763	
L8	(11 same 12) and 16	0	
L7	15 and L6	1	
L6	427/230,231,237.ccls.	1197	
L5	11 and 12 and 13	128	
L4	11 same 12 same L3	1	
L3	tube or tubular or hollow near substrate	888869	
L2	plasma near2 deposition	12668	
L1	voltage near2 puls\$3	52190	
	DB=US L10 L9 L8 L7 L6 L5 L4 L3 L2	L10 (l1 same l2) and L9 L9 427/\$7.ccls. L8 (l1 same l2) and l6 L7 l5 and L6 L6 427/230,231,237.ccls. L5 l1 and l2 and l3 L4 l1 same l2 same L3 L3 tube or tubular or hollow near substrate plasma near2 deposition	

END OF SEARCH HISTORY

WEST Search History

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DATE: Wednesday, September 14, 2005

Hide?	Set Nam	<u>e Query</u>	Hit Count
	DB=US	PT; PLUR=YES; OP=OR	
	L21	12 and 117	2
\Box	L20	15 and 117	0
	L19	117 and 15 and 16	0
	L18	L17 and 14 and 16	0
\Box	L17	112 or 113 or 115	115
	L16	ohtake adj naoto.in.	0
\Box	L15	kondo adj yoshimasa.in.	13
	L14	kondo addj yoshimasa.in.	20778
	L13	nakamura adj yukinori.in.	14
	L12	saito adj takao.in.	88
	L11	17 and L10	1
	L10	427/237.ccls.	415
\Box	L9	17 and L8	32
	L8	427/\$7.ccls.	86763
\square	L7	11 and 15 and L6	226
	L6	pulse near2 voltage	49650
	L5	13 or L4	32226
	L4	pecvd or plasma adj2 deposition	15794
	L3	plasma near3 (cvd or vapor adj deposition)	26916
	L2	substrate near3 L1	5229
	L1	tube or tubular	888569

END OF SEARCH HISTORY